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2. The allowed claim(s) is/are <u>1-8</u> .			
3. \boxtimes The drawings filed on <u>13 April 2004</u> are accepted by the Examir			
	5 U.S.C. § 119(a)-(d) or (f).		
 4. Acknowledgment is made of a claim for foreign priority under 3 a) All b) Some* c) None of the: 1. Certified copies of the priority documents have been 2. Certified copies of the priority documents have been 3. Copies of the certified copies of the priority documents have been International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this noted below. Failure to timely comply will result in ABANDONMENT THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submitted. INFORMAL PATENT APPLICATION (PTO-152) which gives read (a) including changes required by the Notice of Draftsperson's (a) hereto or 2) To Paper No./Mail Date (b) hereto or 2) to Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(c)) each sheet. Replacement sheet(s) should be labeled as such in the hear. 	n received in Application No. Ints have been received in the second communication to file a report this application. Note the attached EXAMINE son(s) why the oath or declar submitted. Patent Drawing Review (PT endment / Comment or in the should be written on the drawing recording to 37 CFR 1.12	nis national stage application of the bounds in the front (not the bounds).	TICE OF
 DEPOSIT OF and/or INFORMATION about the deposit of attached Examiner's comment regarding REQUIREMENT FOR 			te the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. Notice of Informa	I Patent Application (PTO-	152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summa Paper No./Mail D		
3. Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No./Mail Date	7. Examiner's Amen	ndment/Comment	
 Examiner's Comment Regarding Requirement for Deposit of Biological Material 	8. ⊠ Examiner's Stater 9. □ Other	ment of Reasons for Allow Shik-Viao Chen SHIH-CHAO CHEN PRIMARY EXAMINER	ance

Application/Control Number: 10/743,904 Page 2

Art Unit: 2821

DETAILED ACTION

Allowable Subject Matter

1. Claims 1-8 are allowed.

2. The following is an examiner's statement of reasons for allowance:

The prior art of record fails to teach or suggest one or more of the limitations found in independent claim 1. Specifically, with respect to claim 1, the prior art of record (Izadian '936 and Pakray et al. '811) fails to teach or suggest the first radiation element and the grounding conductor being provided on the same surface of the dielectric substrate. Therefore, independent claim 1, as well as all dependent claims, is allowable over the prior art of record.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Communication Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Leith A. Al-Nazer whose telephone number is 571-272-1938. The examiner can normally be reached on Monday-Friday, 7:30-4:00.

Application/Control Number: 10/743,904 Page 3

Art Unit: 2821

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Don Wong can be reached on 571-272-1834. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shin'u Na Cliun Shih-chao chen Primary examiner

LA